

Refine Search

Search Results -

Terms	Documents
(deposit\$3 adj chamber) and (configur\$3) and (wafers) and (measur\$3 adj3 thickness adj3 wafer) and (pattern)	8

Database:

US Pre-Grant Publication Full-Text Database
 US Patents Full-Text Database
 US OCR Full-Text Database
 EPO Abstracts Database
 JPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Search:

L16

Refine Search

Recall Text

Clear

Interrupt

Search History

DATE: Thursday, October 07, 2004 [Printable Copy](#) [Create Case](#)

<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>	<u>Set</u> <u>Name</u> result set
side by side			
<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=NO; OP=OR</i>			
<u>L16</u>	(deposit\$3 adj chamber) and (configur\$3) and (wafers) and (measur\$3 adj3 thickness adj3 wafer) and (pattern)	8	<u>L16</u>
<u>L15</u>	(deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers)	24	<u>L15</u>
<u>L14</u>	(deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers) and (pattern adj5 thickness)	0	<u>L14</u>
<u>L13</u>	(deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers) and (wafer adj3 thickness)	0	<u>L13</u>
<u>L12</u>	(deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers) and (wafer adj3 thickness) and (pattern)	0	<u>L12</u>
<u>L11</u>	(deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers) and (wafer adj3 tickness) and (pattern)	0	<u>L11</u>
<u>L10</u>	(deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers) and (measur\$3 adj tickness) and (pattern)	0	<u>L10</u>

<u>L9</u>	(deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers) and (measur\$3 adj tickness) and (deposition adj pattern)	0	<u>L9</u>
<u>L8</u>	(deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers) and (measur\$3 adj thickness) and (pattern)	23	<u>L8</u>
<u>L7</u>	(deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers) and (thickness) and (pattern)	24	<u>L7</u>
<u>L6</u>	(deposit\$3 adj chamber) and (configur\$3 adj3 parameter) and (wafers) and (thickness) and (pattern)	24	<u>L6</u>
<u>L5</u>	(deposit\$3 adj chamber) and (configur\$3 adj parameter) and (wafers) and (thickness) and (pattern)	0	<u>L5</u>
<u>L4</u>	(deposit\$3 adj chamber) and (configur\$3 adj parameter) and (wafers) and (measur\$3 adj thickness) and (pattern)	0	<u>L4</u>
<u>L3</u>	(deposit\$3 adj chamber) and (configur\$3 adj parameter) and (wafers) and (measur\$3 adj thickness) and (deposition adj pattern)	0	<u>L3</u>
<u>L2</u>	(deposit\$3 adj chamber) and (configur\$3 adj parameter) and (wafers) and (measur\$3 adj tickness)	0	<u>L2</u>
<u>L1</u>	(deposit\$3 adj chamber) and (configur\$3 adj parameter) and (wafers) and (measur\$3 adj tickness) and (deposition adj pattern)	0	<u>L1</u>

END OF SEARCH HISTORY